

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

## Title of Invention

SEMICONDUCTOR DEVICE AND FABRICATION PROCESS  
THEREFOR

Application Number :

Confirmation Number:

First Named Applicant: Lloyd Burrell

Attorney Docket Number: FIS920030011US1

Art Unit:

Examiner:

Search string: ( 5391516 or 6350667 or 5523626 or 20020068385 or 20010051426 ).pn

## US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
P.M	1	5391516	1995-02-21	WOJNAROWSKI, ET AL.			
A.M	2	6350667	2002-02-26	CHEN, ET AL.			
A.M	3	5523626	1996-06-04	HAYASHI, ET AL.			

## US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

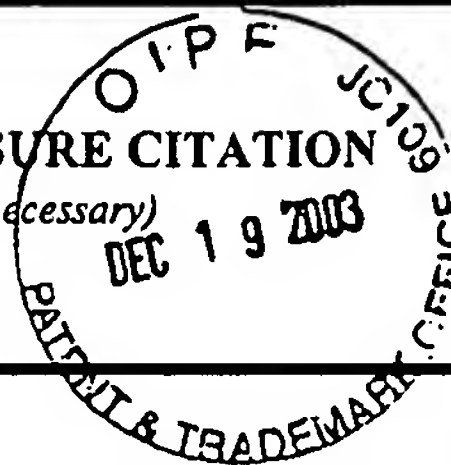
init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
A.M	1	20020068385	2002-06-06	MA, ET AL.			
A.M	2	20010051426	2001-12-13	POZDER, ET AL.			

## Signature

Examiner Name	Date
ANH D. MAI	10/05/04

# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional)

FIS920030011US1

Application Number

10/605,369

Applicant(s)

LLOYD BURELL, ET AL.

Filing Date

10/25/03

Group Art Unit

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
A.M		6,242,078	6/05/01	Pommer et al.	428	290	
A.M		6,435,398	8/20/02	Hartfield et al.	228	103	

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
P.M		JP0008821A2		JAPAN				

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

ANH D. MAI

DATE CONSIDERED

10/05/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.